IN THE SPECIFICATION:

[SF-1114111v1]

Please amend the paragraph beginning on page 1 at line 12 to read as follows:

This is a continuation of application serial number 09/610,667 entitled REFLECTOMETRY SYSTEM WITH COMPENSATION FOR SPECIMEN HOLDER TOPOGRAPHY AND WITH LOCK-REJECTION OF SYSTEM NOISE which will issue as U.S. patent no. 6,584,217 on June 24, 2003, which was a continuation of application serial number 09/021,419 filed on February 10, 1998, which was a continuation-in-part from application serial number 08/465,089 entitled OPTICAL SPECIMEN ANALYSIS SYSTEM AND METHOD, which issued will issue as U.S. patent no. 5,717,778 on February 10, 1998, and from application serial number 08/995,590 entitled OPTICAL SPECIMEN ANALYSIS SYSTEM AND METHOD, filed on December 22, 1997, a continuation of said serial number 08/465,089. Applicants incorporate each said application herein by reference.

A-65430-2/DJB/MAK (filed herewith) -2-